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AAR*

PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Takeshi MITSUISHI et al.) Group Art Unit: 2872
)
Application No.: 09/986,907) Examiner: J. Pritchett
)
Filed: November 13, 2001)
)
For: COMPOSITION FOR VAPOR)
DEPOSITION, METHOD FOR)
FORMING AN ANTIREFLECTION)
FILM, AND OPTICAL ELEMENT)

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Commissioner for Patents
Washington, DC 20231

Sir:

REPLY

This reply is filed in response to the Office Action of October 22, 2002. A request for a one month extension of time and the appropriate fee are being filed concurrently with this reply. Prompt and favorable reconsideration of this application is requested in view of the remarks provided below.

REMARKS

Claims 1-17 are pending in this application.

The Examiner has indicated that copending application 09/995,827 was considered but that the citation was lined through on the Information Disclosure Statement because applications are not printed on the patent when a patent is published. Applicants are submitting another copy of the PTO 1449 and request that the Examiner initial the citation and not place a line through the citation since it makes

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